

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Minoru Toriumi, et al.

Title:

GROUP 1700 RESIST COMPOSITION AND METHOD FOR MANUFACTURING

SEMICONDUCTOR DEVICE USING THE RESIST COMPOSITION

Appl. No.:

09/925,679

Filing Date:

February 21, 2002

Examiner:

J. Chu

Art Unit:

1752

## **INFORMATION DISCLOSURE STATEMENT** UNDER 37 CFR §1.56

Commissioner for Patents **Box PATENT APPLICATION** Washington, D.C. 20231

Sir:

Submitted herewith on Form PTO/SB/08 is a listing of documents known to Applicants in order to comply with Applicants' duty of disclosure pursuant to 37 CFR §1.56. A copy of each listed document is being submitted to comply with the provisions of 37 CFR §1.97 and §1.98.

The submission of any document herewith, which is not a statutory bar, is not intended as an admission that such document constitutes prior art against the claims of the present application or that such document is considered material to patentability as defined in 37 CFR §1.56(b). Applicants do not waive any rights to take any action which would be appropriate to antedate or otherwise remove as a competent reference any document which is determined to be a prima facie art reference against the claims of the present application.



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## TIMING OF THE DISCLOSURE

The listed documents are being submitted in compliance with 37 CFR §1.97(c), before the mailing date of either a final action under 37 CFR §1.113, a notice of GROUP 1200 allowance under 37 CFR §1.113, or an action that otherwise closes prosecution in the application.

## RELEVANCE OF EACH DOCUMENT

Document A1 relates to positive photosensitive composition.

Document A2 relates to photoresist composition.

Document A3 relates to photoresist composition containing cyclic olefin polymer and additive.

Documents A1-A3 listed on the attached PTO/SB/08 were cited as being relevant during the prosecution of the corresponding Japanese application. Englishlanguage counterparts of the foreign-language documents have not been provided. The absence of a translation or an English-language counterpart document does not relieve the PTO from its duty to consider any submitted document (37 CFR §1.98 and MPEP§609). English-language abstracts are attached.

Applicants respectfully request that any listed document be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO/SB/08 be returned in accordance with MPEP §609.

## **STATEMENT**

The undersigned hereby states in accordance with 37 CFR §1.97(e)(1) that each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to filing of this Statement.





The Commissioner is hereby authorized to charge any additional fees which may solve application under 37 CFR §§ 1.16-1.17, or credit any be required regarding this application under 37 CFR §§ 1.16-1.17, or credit any overpayment, to Deposit Account No. 19-0741. Should no proper payment be enclosed herewith, as by a check being in the wrong amount, unsigned, post-dated, otherwise improper or informal or even entirely missing, the Commissioner is authorized to charge the unpaid amount to Deposit Account No. 19-0741.

Respectfully submitted,

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